INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket number (Optional)	Application Numbe
4-444 44 -	1

15689.49.7

10/674,003

Applicant(s)

Takehiro Nakamura et al.

Filing Date

Group Art Unit

September 29, 2003

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*EXAMINER	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING	
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	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Trans	lation
					CAREGO		YES	NO
	1	0 682 418 A2	05/12/1995	EPO	H0487	005	X	
	2	CN1126930	7/17/1996	China	H04B7	005	X	
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*Examiner Initial	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)					
	3	Chinese Office Action for Chinese Patent Application No.: 20031010330.1				
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EXAMINER		DATE CONSIDERED				

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